

Notice of References Cited	Application/Control No. 10/698,042	Applicant(s)/Patent Under Reexamination STEINTHAL ET AL.	
	Examiner Toan M. Le	Art Unit 2863	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,759,010	07-2004	Lewis et al.	422/82.02
	B	US-6,350,369	02-2002	Lewis et al.	205/777.5
	C	US-6,823,717	11-2004	Porter et al.	73/31.05
	D	US-6,773,926	08-2004	Freund et al.	436/149
	E	US-6,330,464	12-2001	Colvin et al.	600/316
	F	US-5,963,369	10-1999	Steinthal et al.	359/410
	G	US-6,711,423	03-2004	Colvin, Jr., Arthur E.	600/317
	H	US-6,700,484	03-2004	Bartholomew et al.	340/531
	I	US-6,627,154	09-2003	Goodman et al.	422/82.01
	J	US-6,606,567	08-2003	Grate et al.	702/22
	K	US-6,868,350	03-2005	Zimmermann et al.	702/65
	L	US-6,854,317	02-2005	Porter et al.	73/31.05
	M	US-6,017,440	01-2000	Lewis et al.	205/777.5

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Ziegler et al., Bioelectronic Noses: A Status Report. Part II, 1998, Biosensors & Bioelectronics 13, Pages 539-571
	V	Porter et al., Sensor Based on Piezoresistive Microcantilever Technology, 2001, Sensors and Actuators A 88, Pages 47-51
	W	McKennoch et al., Electronic Interface Modules for Solid-State Chemical Sensors, 2002 IEEE, Pages 344-349
	X	Zee et al., MEMS Chemical Gas Sensor Using a Polymer-Based Array, June 7-10, 1999, The 10th International Conference on Solid-State Sensors and Actuators

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.